



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 3, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG816634363

LABORATORY GROWN DIAMOND

OVAL BRILLIANT

13.26 x 9.14 x 5.62 mm

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

4.23 CARATS

D

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

EXCELLENT

NONE

IGI LG816634363

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG816634363

Report verification at igi.org

PROPORTIONS

14%

44%

44.2%

60%

61.5%

Pointed

Medium To Slightly Thick (Faceted)



Sample Image Used

LIGHT PERFORMANCE REPORT

Light Performance Grade: Exceptional



Structured Light Environment Representation

Moderate

High

Superior

Exceptional

Light Performance

Brightness

Fire

Contrast

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



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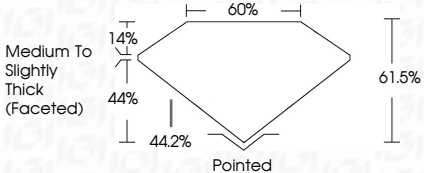
EXCELLENT

EXCELLENT

NONE

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IGI

July 3, 2026

IGI Report No LG816634363

OVAL BRILLIANT

13.26 X 9.14 X 5.62 MM

Carat Weight

Color Grade

Clarity Grade

Table

Depth

Girdle

Medium To Slightly Thick (Faceted)

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

4.23 CARATS

D

VVS 2

61.5%

60%

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG816634363

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